

TITRE DE LA PUBLICATION OU DE LA PRÉSENTATION TECHNIQUE

ANOMALIES IN MODELING OF ANISOTROPIC ETCHING OF SILICON

MODELLING OF ANISOTROPIC ETCHING OF SILICON : ANOMALIES DUE TO FACET BOUNDARY EFFECTS

STEP-BASED FACET INTERACTIONS IN WET ANISOTROPIC ETCHING

MODELLING AND ANALYSIS OF STEP-BASED SILICON SURFACES AT FACET BOUNDARIES DURING WET ANISOTROPIC ETCHING

SILICON WET ETCH ANISOTROPY: ANALYSIS OF THE EFFECT OF {111}, {110} {100} TERRACE WIDTHS

EFFECT OF LIGHT ILLUMINATION ON ETCH RATES OF SILICON SURFACES IN ANISOTROPICALLY ETCHED CONCAVE STRUCTURES

PULSED LASER DEPOSITION OF CAXBA1-XNB2O6 THIN FILM ON NANO-PATTERNED SILICON SUBSTRATE

PULSED LASER DEPOSITION OF THICK LAYERS OF CAXBA1-XNB2O6 FILM

NANO-PATTERN ON SILICON SUBSTRATE FOR PULSED LASER DEPOSITION OF CAXBA1-XNB2O6 THIN FILM

IMPEDIMETRIC IMMUNOSENSORS BASED ON NANOGAP INTERDIGITATED GOLD ELECTRODE ARRAY PLATFORM, ACCEPTED

ROBUST NANO-ELECTRODE ARRAY PLATFORM FOR MULTIPLE CANCER BIOMARKER DETECTION

A LABEL-FREE MULTIPLEXED IMPEDANCE-BASED IMMUNOSENSOR FOR BRAIN TUMOR BIOMARKERS

ARRAY OF NANO-ELECTRODES FOR CANCER MULTI-BIOMARKER DETECTION

IS IT POSSIBLE TO COLLABORATE IN A VERY COMPETITIVE MEMS MARKET

HOW MAY WE ASSIST YOU IN YOUR INNOVATION? (FROM YOUR CHALLENGES TO OUR ROADMAP)

VERSATILITY VS .PRODUCTION, DEVELOPMENT CENTRE NEVER-ENDING STRUGGLE

ANOMALIES IN MODELLING OF ANISOTROPIC ETCHING OF SILICON

STEP-BASED FACET INTERACTIONS IN WET ANISOTROPIC ETCHING

MODELLING OF ANISOTROPIC ETCHING OF SILICON: ANOMALIES DUE TO FACET BOUNDARY EFFECTS

ANALYSIS OF STEP-BASED SILICON SURFACES AT FACET BOUNDARIES DURING WET ANISOTROPIC ETCHING

SILICON WET ETCH ANISOTROPY: ANALYSIS OF THE EFFECT OF {111}, {110} {100} TERRACE WIDTHS

CALCIUM, BARIUM NOBITE RIDGE WAVEGUIDE ON SILICON SUBSTRATE

FABRICATION OF A SILICON-BASED CAXBA1-XNB2O6 RIDGE WAVEGUIDE FOR ELECTRO-OPTICAL PHASE MODULATION

LOW LOSS CAXBA1-XNB2O6 RIDGE WAVEGUIDE FOR ELECTRO-OPTIC DEVICES

STUDIES ON SELF-ASSEMBLED ZNO NANORODS/NANOWIRES GROWN ON SILICON SUBSTRATES BY ELECTROCHEMICAL DEPOSITION

ROBUST NANOWIRE ELECTRODES ARRAY PLATFORM FOR BIOSENSING APPLICATIONS

DESIGN AND FABRICATION OF INTEGRATED MULTI-ANALYTE SENSING PLATFORM WITH MAGNETIC MICRO-COILS

VACUUM-ASSISTED WET PROCESSING FOR ADVANCED 3D DEVICES

THIN FILMS RESIDUAL STRESS PROFILE EVALUATION USING TEST MICROSTRUCTURES: ILLUSTRATED ON AN EXAMPLE OF ALN FILM

ROBUST NANOWIRE ELECTRODES ARRAY PLATFORM FOR BIOSENSING APPLICATIONS

ROBUST NANO-ELECTRODE ARRAY PLATFORM FOR MULTIPLE CANCER BIOMARKER DETECTION

A LABEL-FREE MULTIPLEXED IMPEDANCE-BASED IMMUNOSENSOR FOR BRAIN TUMOR BIOMARKERS

IMPEDIMETRIC IMMUNOSENSORS BASED ON NANOGAP INTERDIGITATED GOLD ELECTRODE ARRAY PLATFORM

EXPERIMENTS OF AIR BUBBLES IMPACTING A RIGID WALL IN TAP WATER

EUMELANIN THIN FILMS AND METAL ELECTRODES: NANOSTRUCTURES FORMATION UNDER ELECTRICAL BIAS FOR MEMORY APPLICATIONS

VOID FRACTION INFLUENCE ON ADDED MASS IN BUBBLY FLOW

RESISTIVE SWITCHING CONTROLLED BY THE HYDRATION LEVEL IN THIN FILMS OF THE BIOPIGMENT EUMELANIN

HOW MAY WE ASSIST YOU IN YOUR INNOVATION? (FROM YOUR CHALLENGES TO OUR ROADMAP)

GREEN BODY STRENGTH IN BINDER JETTING THREE-DIMENSIONAL PRINTING

INFLUENCE OF VACUUM ON STAINLESS STEEL 316L SINTERING IN METALLIC ADDITIVE MANUFACTURING THROUGH BINDER JETTING

APPLICATION OF MACHINE LEARNING TO PREDICT THE DENSITY OF BINDER-JET 3D PRINTED PARTS

EXPERIMENTAL PROTOCOLS FOR POLYMERIC BINDER SELECTION IN THE BINDER JETTING OF METALLIC PARTICLES IN THREE-DIMENSIONAL PRINTING

GOLD STUD BUMPS THERMOCOMPRESSSION BONDING FOR MEMS PACKAGING - CRITICAL ISSUE FOR RELIABILITY

SYSTEM AND METHOD FOR MEDICAL ULTRASOUND WITH MONITORING PAD AND MULTIFUNCTION MONITORING SYSTEM

VERSATILITY VS .PRODUCTION, DEVELOPMENT CENTRE NEVER-ENDING STRUGGLE

TAKING YOUR MEMS AND PHOTONIC CHIPS TO ANOTHER LEVER WITH C2MI

CHARACTERIZATION OF THE SARCOPLASMIC RETICULUM K⁺ AND CA²⁺ + RELEASE CHANNEL - RYANODINE RECEPTOR - IN HUMAN ATRIAL CELLS

CARACTÉRISATION ÉLECTROPHYSIOLOGIQUE ET BIOCHIMIQUE DES DIFFÉRENTS CANAUX IONIQUES DU RÉTICULUM SARCOPLASMIQUE DES CELL

SARCOPLASMIC RETICULUM K⁺ CHANNELS FROM HUMAN AND SHEEP TRIAL CELLS DISPLAY A SPECIFIC ELECTRO-PHARMACOLOGICAL PROFILE

SILICON WET ETCH ANISOTROPY: ANALYSIS OF THE EFFECT OF {111}, {110} {100} TERRACE WIDTHS

ACOUSTOMETRICS SYSTEM AND METHODS FOR REAL TIME MONITORING STRUCTURAL INTEGRITY OF METALLIC AND NON-METALLIC

METHOD AND SYSTEM FOR VIRTUALLY DELIVERING SOFTWARE APPLICATIONS TO REMOTE CLIENTS

LOW LOSS CAXBA1-XNB2O6 RIDGE WAVEGUIDE FOR ELECTRO-OPTIC DEVICE

CALCIUM, BARIUM NOBITE RIDGE WAVEGUIDE ON SILICON SUBSTRATE

LID EDGE CAPPING LOAD

SIO₂ SHALLOW STRUCTURES ICP ETCHING USING ZEP ELECTRORESIST

THREE DIMENSIONAL ELECTRON MICROSCOPY SIMULATION WITH THE CASINO MONTE CARLO SOFTWARE

DESIGN AND FABRICATION OF INTEGRATED MULTI-ANALYTE SENSING PLATFORM WITH MAGNETIC MICRO-COILS

STUDIES ON SELF-ASSEMBLED ZNO NANORODS/NANOWIRES GROWN ON SILICON SUBSTRATES BY ELECTROCHEMICAL DEPOSITION

TECHNOLOGY PLATFORM FOR THE FABRICATION OF TITANIUM NANOSTRUCTURES 6FG06-06FG06-4

MULTI-CHIP ELECTRONIC PACKAGES AND METHODS OF MANUFACTURE

VACUUM-ASSISTED WET PROCESSING FOR ADVANCED 3D DEVICES

DESIGN AND FABRICATION OF INTEGRATED MULTI-ANALYTE SENSING PLATFORM WITH MAGNETIC MICRO-COILS

GROUNDED LID FOR MICRO-ELECTRONIC ASSEMBLIES

A DAMASCENE PLATFORM FOR CONTROLLED ULTRA-THIN NANOWIRE FABRICATION

LAMINATE PERIPHERAL CLAMPING TO CONTROL MICROELECTRONIC MODULE BSM WARPAGE

ADDRESSING FLUX DIP CHALLENGES FOR 3D INTEGRATED LARGE DIE - ULTRA-FINE PITCH INTERCONNECT

PRÉSENTATION D'ESSAIS "RELIABILITY OF PRINTED WIRE BONDS"

RECUIT À L'HYDROGÈNE POUR LA RÉDUCTION DE LA RUGOSITÉ DES PAROIS DANS UN CONTEXTE INDUSTRIEL DE MICROFABRICATION DE MEMS

SYSTEM AND METHOD FOR MEDICAL ULTRASOUND WITH MONITORING PAD

FEW-CYCLE YB LASER SOURCE AT 20 KHZ USING MULTIDIMENSIONAL SOLITARY STATES IN HOLLOW-CORE FIBERS.

COPPER HYBRID PRINTING SOLUTION FOR FLEXIBLE ELECTRONIC MANUFACTURING

PRESENTATION OF C2MI'S CAPABILITIES IN HYBRID PRINTING SOLUTIONS USING COP

PRINTED AND FLEXIBLE ELECTRONICS FOR AUTOMOTIVE APPLICATIONS : TECHNOLOGIES AND MARKETS

HOW A MORE HOLLISTIC APPROACH TO FABRICATION WILL ENABLE BETTER AND MORE COMPLEX SENSORS

AN APPROACH USING ACTIVE STRUCTURAL ACOUSTIC CONTROL FOR THE REDUCTION OF STRUCTURE-BORNE ROAD NOISE

ON-RESONANCE TRANSMISSIBILITY METHODOLOGY FOR QUANTIFYING THE STRUCTURE-BORNE ROAD NOISE OF AN AUTOMOTIVE SUSPENSION ASSEMBLY INTERNATIONALES)

REDUCTION OF STRUCTURE-BORNE NOISE IN AUTOMOBILES BY MULTIVARIABLE FEEDBACK

AN ACTIVE STRUCTURAL ACOUSTIC CONTROL APPROACH FOR THE REDUCTION OF STRUCTURE-BORNE ROAD NOISE.

RELIABILITY OF PRINTED WIRE BONDS - PUBLISHED ON C2MI'S WEBSITE ON OCTOBER 31ST, 2019

MASKLESS LITHOGRAPHY MICROFABRICATION FOR HIGH VOLUME FABRICATION

A MASKLESS ALIGNER STRATEGY FOR FABRICATION MEMS FROM PROTOTYPING TO HIGH VOLUME MANUFACTURING

NANOSCALE SiO₂ SHALLOW STRUCTURES ICP ETCHING, M. GUILMAIN, A. JOUAD, S. ECOFFEY ET D. DROUIN

EXPERIMENTAL PROTOCOLS FOR POLYMERIC BINDER SELECTION IN THE BINDER JETTING OF METALLIC PARTICLES IN THREE-DIMENSIONAL PRINTING

MODEL APPROACH FOR BINDER SELECTION IN BINDER JETTING

UTILISATION DE VIDE DANS LES PROCÉDÉS LIQUIDES DE MIQROFABRICATION DE MEMS

VOID FRACTION EFFECT ON ADDED MASS IN BUBBLY FLOW ASME pressure vessels and piping conference

TRE DE PUBLICATIONS SCIENTIFIQUES

SOURCE / MEDIA	ANNÉE DE PUBLICATION
10th Canadian Semiconductor Conference, Ottawa	2001
3rd Workshop on Physical Chemistry of Wet Chemical Etching of Silicon, Nara, Japan	2002
CCECE, Montreal	2003
11th Canadian Semiconductor Conference, Ottawa	2003
4th on Physical Chemistry of Wet Chemical Etching of Silicon, Montreal	2004
13th Canadian Semiconductor Conference, Montreal	2007
Nanotech 2009, Houston, TX	2009
Colloque de Plasma-Québec, Montreal, QC	2009
92nd Canadian Chemistry Conference, Hamilton, ON	2009
21st Anniversary World Congress on Biosensors, Cancun, Mexico	2012
2nd International Conference on Bio-Sensing Technology, Amsterdam	2011
NanoQuebec	2012
NanoQuebec	2012
MWS, Munich	2019
MWS, Munich	2020
MWS webinar, Munich	2022
Journal of Vacuum and Science Technology A	2002
CCECE	2003
Sensors and Materials Magazine	2003
Journal of Vacuum and Science Technology A	2004
Sensors and Materials Magazine	2005
Journal of Optical Engineering	2010
Semiconductor Science and Technology Magazine	2010
Microelectronic Engineering Magazine	2011
Advances in Heterogeneous Material Mechanics: Proceedings	2011
Nanotech 2011 Conference, Boston	2011
IEEE Journal of MEMS, Vol.22(6), pp. 1339-1346	2013
Conference Proceedings of IWLPCC,	2013
Journal of Vacuum and Science Technology B	2021
Nanotech 2011 Conference, Boston	2011
2nd International Conference on Bio-Sensing Technology, Amsterdam	2011
NanoQuébec	2012
21st Anniversary World Congress on Biosensors, Cancun, Mexico	2012
Physics of fluids, 27, 12, 16 PGS.	2015
Material research society fall meeting Conference, Boston	2015
European Journal of Mechanics, B/FLUIDS 56, 28-45.	2016

Journal of material Chemistry C, 4 (40), 9544-9553	2016
MWS, Munich	2020
Conference CCEC, Montréal	2020
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Conference CCEC, Montréal	2020
Mémoire de Maîtrise	2021
Site internet C2MI	2023
WO2022170439A1	2022
MWS webinar, Munich	2022
Atelier au LAB2FAB	2022
Journal of molecular and cellular cardiology	2000
Mémoire de Maîtrise	2000
Journal of Molecular Cell Cardiology	2002
4th on Physical Chemistry of Wet Chemical Etching of Silicon, Montreal	2005
Brevet - Confidentiel	2006
W02009127067A1	2009
Microelectronic Engineering, Vol. 88, 3, pp. 218-221	2011
Journal of Optical Engineering, Vol. 49, 074601, Ridge Waveguide on Silicon Substrate	2010
Brevet US 20100020503 A1 (7733655 B2)	2010
MICROELECTRONICS ENGINEERING, VOL. 88,8 , 2505-2508	2010
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IEEE Journal of MEMS, Vol.22(6), pp. 1339-1346	2013
Advances in Heterogeneous Material Mechanics: Proceedings	2011
Journal of Vacuum Science & Techn. B : Microelectronics and nanometer structures, Vol. 29,6	2011
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Conference Proceedings of IWLPC	2013
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Brevet US 20110292621 A1 (8614900 B2)	2013
Nanotechnology, vol. 24, 24, 245305	2013
Brevet US 2014359996 A1 (9219051 B2)	2014
Site internet C2MI	2017
IMAPS Congress	2019
White paper - Site internet + infolettre C2MI	2019
PCT/CA2020/051108	2020
OPT. LETT, 47, 3612-3615,	2020
Flex Conference & Exhibition, Semicon West	2022
CPES Symposium	2022
IDTECHEX - ICHEHET Express Conference	2022
MEMS SENSORS TECHNICAL Congress-MSTC 2023	2023
LAP Lambert Academic Publishing (2011-09-12), ISBN-13: 978-3-8443-9722-2, ISBN-10: 3844397221, EAN, 9783844397222, 240 pp.	2011
Applied Acoustics Journal, 2006; 67(2):25 pp. (SCORE : Référencés dans 38 publications	2006

IEEE Conference on Control Applications, Toronto	2005
144th meeting of the Acoustical Society of America, Cancun, Mexique	2002
Site internet C2MI	2019
Semiconductor Digest- Dec 2020	2020
MEMS SENSORS TECHNICAL CONGRES- MSTC 2022	2022
36th International Conference on Micro&Nano Engineering (MNE 2010), Italie	2010
Mémoire de Maîtrise	2021
Industrial & Engineering Chemistry Research	2021
White paper - Site internet + infolettre C2MI	2019
EUROPEAN JOURNAL OF MECHANICS, B/FLUIDS 56, 28-45., Anaheim, CA	2016

AUTEUR(S)	TYPE DE PUBLICATION
Z. Elalamy, L. M. Landsberger, M. Kahrizi, A. Pandey, I. Stateikina , S. Michel,	Présentation technique Orale
Z. Elalamy, L. M. Landsberger, M. Kahrizi, A. Pandey, I. Stateikina , S. Michel	Présentation technique Orale
I. Stateikina , Z. Elalamy, L. M. Landsberger, M. Kahrizi	Présentation technique Orale
I. Stateikina , L. M. Landsberger, M. Kahrizi,	Présentation technique Poster
I. Stateikina , N. Hoque, L. M. Landsberger, V. Rossokhaty, Z. Elalamy, M. Kahrizi	Présentation technique Orale
I. Stateikina , L. M. Landsberger, M. Kahrizi	Présentation technique Poster
I. Stateikina , S. Delprat, M. Chaker,	Présentation technique Poster
I. Stateikina , M. Chaker	Présentation technique Poster
I. Stateikina , S. Delprat, M. Chaker,	Présentation technique Poster
I. Stateikina , C. Tlili, M. Zourob	Présentation technique Orale
I. Stateikina , C. Tlili, R. Elshafey, M. Zourob	Présentation technique Poster
R. Elshafey, A. Ng, C. Tlili, I. Stateikina , A. Abulrob, A. Tavares, M. Chaker, and M. Zourob	Présentation technique Poster
I. Stateikina , R. Elshafey, C. Tlili, M. Zourob and M. Chaker,	Présentation technique Poster
I. Stateikina	Présentation technique Orale
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Z. Elalamy, L. M. Landsberger, A. Pandey, M. Kahrizi, I. Stateikina , S. Michel	Publication
I. Stateikina , Z. Elalamy, L. M. Landsberger, M. Kahrizi,	Présentation technique Orale
Z. Elalamy, L. M. Landsberger, M. Kahrizi, A. Pandey, I. Stateikina , S. Michel	Publication
I. Stateikina , M.-Z. Elalamy, L. M. Landsberger, M. Kahrizi,	Publication
I. Stateikina , N. Hoque, L. M. Landsberger, V. Rossokhaty, Z. Elalamy, M. Kahrizi,	Publication
E. Mortazy, I. Stateikina , A. Tehranichi, S. Delprat, M. Chaker, and Ke Wu	Publication
I. Stateikina , E. Mortazy, S. Delprat, Ke Wu, and M. Chaker	Publication
E. Mortazy, I. Stateikina , A. Tehranichi, S. Delprat, M. Chaker, and Ke Wu	Publication
I. Stateikina	Publication
I. Stateikina , R. Elshafey, A. Ng, M. Uddin Ahmed, and M. Zourob	Présentation technique Orale
I. Stateikina , S. Eissa, and M. Zourob,	Publication
J. Rieker, G. Chen, I. Kashkoush, D. Michel, P. Daoust, and I. Stateikina	Présentation technique Orale
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A. Goffin, S.I. Yanez Sanchez , D. Schlachter, S. Hosseini Rad, M. Lennox, B.D. Favis, D. Therriault.	Présentation technique Orale
J.R. Tavares	
Tavares	Présentation technique Orale
L. Arias	Mémoire de Maîtrise
C. Marsan-Loyer	Publication
Valois M. , Lanctôt J-F, Douville H. et al.	Brevet
I.Stateikina	Présentation technique Orale
K.Côté	Présentation technique Orale
K. Côté , S. Proteau, J. Teijeira et E. Rousseau	Publication
K.Côté	Mémoire de Maîtrise
I. Picard, K. Côté , J. Teijeira, D. Greentree and E. Rousseau	Publication
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Douville, H.	Brevet
Chandelier F., Douville H.	Brevet
E. Mortazy, I. Stateikina , A. Tehranichi, S. Delprat, M. Chaker, and Ke Wu,	Publication
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M.Beaumier	Brevet
M. Guilmain , A. Jouad, S. Ecoffey et D. Drouin	Publication
H. Demers, N. Poirier-Demers, A.R. Couture, D. Joly, M. Guilmain, N. De Jonge, D. Drouin	Publication
I. Stateikina , S. Eissa, and M. Zourob	Présentation technique Orale
S. Spitsina, I. Stateikina , M. Chaker, and M. Kahrizi,	Publication
S. Ecoffey, M. Guilmain , J.F. Morissette, F. Bourque, J. Pont, B. Lee Sang et D. Drouin	Publication
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I. Stateikina , S. Eissa, and M. Zourob	Publication
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M. Beaumier	Brevet
C. Marsan-Loyer , D. Danovitch, N. Boyer	Publication
C.Marsan-Loyer	Présentation technique Orale
I.Stateikina	Publication
Valois M. , Lanctôt J-F, Douville H. et al.	Brevet
L. Arias , A. Longa et al.	Publication
C. SansRegret	Présentation technique Orale
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K.Côté	Présentation technique Orale
Hugo Douville	Publication
H. Douville et al.	Publication

M.P. Jolicoeur, J.G. Roumy, S. Vanreusel, D. Dionne, **H. Douville**, B. Boulet et al.,

H. Douville et al.

C. Marsan-Loyer, C. SansRegret

K.Côté

K.Côté

M.Guilmain, S. Ecoffey, D. Drouin

S.I. Yanez Sanchez

S. I. Yanez Sanchez

I. Stateikina

C. Béguin, **É. Pelletier**, S. Étienne

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	Sergio I. Yanez Sanchez
	Irina Stateikina
	Sergio I. Yanez Sanchez
	Sergio I. Yanez Sanchez
	Sergio I. Yanez Sanchez
Polytechnique Montréal	Loïc Arias
	Catherine Marsan-Loyer
	Hugo Douville
	Irina Stateikina
	Karel Côté
	Karel Côté
Université de Sherbrooke	Karel Côté
	Karel Côté
	Irina Stateikina
	Hugo Douville
	Hugo Douville
	Irina Stateikina
	Irina Stateikina
	Martin Beaumier
	M. Guilmain
	D. Drouin
	Irina Stateikina
	Irina Stateikina
	M.Guilmain
	Martin Beaumier
	Irina Stateikina
	Irina Stateikina
	Martin Beaumier
	M. Guilmain
	Martin Beaumier
	Catherine Marsan-Loyer
	Catherine Marsan-Loyer
	Irina Stateikina
	Hugo Douville
	Loïc Arias
	Christophe Sansregret
	Christophe Sansregret
	Christophe Sansregret
	Karel Côté
	Hugo Douville
	Hugo Douville

	Hugo Douville
	Hugo Douville
	Catherine Marsan-Loyer, Christophe SansRegret
	Karel Côté
	Karel Côté
	M. Guilmain
Polytechnique Montréal	Sergio I. Yanez Sanchez
	Sergio I. Yanez Sanchez
	Irina Stateikina
	Étienne Pelletier